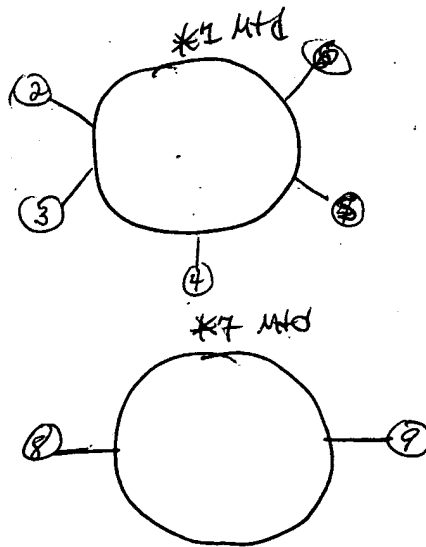


sp/628,459

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Examiner's Notes



Motivation: Good crystal orientation on the substrate. Align a-axis + b-axis in direction of electricity flow & align c-axis in another direction

Day : Monday  
Date: 5/22/2006


**PALM INTRANET**

Time: 12:51:29

**Inventor Name Search Result**

Your Search was:

Last Name = IIJIMA

First Name = YASUHIRO

Application#	Patent#	Status	Date Filed	Title	Inventor Name
<u>07889119</u>	Not Issued	166	05/26/1992	PARALLEL REAL-TIME VIDEO PROCESSOR APPARATUS	IIJIMA, YASUHIRO
<u>07955803</u>	5995706	150	10/02/1992	SOUND EDITING APPARATUS	IIJIMA, YASUHIRO
<u>07956077</u>	Not Issued	161	10/02/1992	METHOD OF MAKING POLYCRYSTALLINE THIN FILM AND SUPERCONDUCTING OXIDE BODY	IIJIMA, YASUHIRO
<u>07992967</u>	Not Issued	166	12/11/1992	DESIRED REGION SPECIFYING SYSTEM IN AN IMAGE EDITING APPARATUS	IIJIMA, YASUHIRO
<u>08155647</u>	Not Issued	161	11/22/1993	METHOD OF MAKING POLYCRYSTALLINE THIN FILM AND SUPERCONDUCTING OXIDE BODY	IIJIMA, YASUHIRO
<u>08341166</u>	5732164	250	11/16/1994	PARALLEL VIDEO PROCESSOR APPARATUS	IIJIMA, YASUHIRO
<u>08353375</u>	6448959	150	12/02/1994	DESIRED REGION SPECIFYING SYSTEM IN AN IMAGE EDITING APPARATUS	IIJIMA, YASUHIRO
<u>08510772</u>	5650378	150	08/03/1995	METHOD OF MAKING POLYCRYSTALLINE THIN FILM AND SUPERCONDUCTING OXIDE BODY	IIJIMA, YASUHIRO
<u>08516193</u>	Not Issued	166	08/17/1995	CHEMICAL VAPOR DEPOSITION REACTOR AND METHOD OF PRODUCING OXIDE SUPERCONDUCTIVE	IIJIMA, YASUHIRO

				CONDUCTOR USING THE SAME	
<u>08889178</u>	<u>5908507</u>	150	07/07/1997	CHEMICAL VAPOR DEPOSITION REACTOR AND METHOD OF PRODUCING OXIDE SUPERCONDUCTIVE CONDUCTOR USING THE SAME	IIJIMA, YASUHIRO
<u>09091231</u>	<u>6214772</u>	150	06/18/1998	PROCESS FOR PREPARING POLYCRYSTALLINE THIN FILM, PROCESS FOR PREPARING OXIDE SUPERCONDUCTOR, AND APPARATUS THEREFOR	IIJIMA, YASUHIRO
<u>09784209</u>	<u>6495008</u>	150	02/16/2001	METHOD FOR MAKING POLYCRYSTALLINE THIN FILM AND ASSOCIATED OXIDE SUPERCONDUCTOR AND APPARATUS THEREFOR	IIJIMA, YASUHIRO
<u>09857912</u>	<u>6716796</u>	150	06/11/2001	POLYCRYSTALLINE THIN FILM AND METHOD OF PRODUCING THE SAME AND OXIDE SUPERCONDUCTOR AND METHOD OF PRODUCING THE SAME	IIJIMA, YASUHIRO
<u>09890052</u>	<u>6632539</u>	150	07/25/2001	POLYCRYSTALLINE THIN FILM AND METHOD FOR PREPARING THEREOF, AND SUPERCONDUCTING OXIDE AND METHOD FOR PREPARATION THEREOF	IIJIMA, YASUHIRO
<u>09958367</u>	<u>6783636</u>	150	10/05/2001	Method of producing polycrystalline thin film of MgO	IIJIMA, YASUHIRO
<u>09974972</u>	<u>6610632</u>	150	10/12/2001	TAPE-FORMED OXIDE SUPERCONDUCTOR	IIJIMA, YASUHIRO
<u>10259386</u>	<u>7006354</u>	150	09/30/2002	HEAT RADIATING STRUCTURE FOR ELECTRONIC DEVICE	IIJIMA, YASUHIRO
<u>10478063</u>	Not Issued	30	06/07/2004	Method of preparing oxide crystal film/substrate composite and solution for use therein	IIJIMA, YASUHIRO
<u>10628459</u>	Not Issued	30	07/29/2003	Method of producing polycrystalline thin film and method of producing an oxide superconducting element	IIJIMA, YASUHIRO

<a href="#">10634030</a>	Not Issued	61	08/04/2003	Oxide superconducting wire	IIJIMA, YASUHIRO
<a href="#">10787309</a>	Not Issued	61	02/27/2004	Heat radiating structure for electronic device	IIJIMA, YASUHIRO
<a href="#">10886511</a>	Not Issued	30	07/07/2004	Coupling device and wiper blade	IIJIMA, YASUHIRO
<a href="#">60330618</a>	Not Issued	159	10/26/2001	Heat dissipation structure for electronic device	IIJIMA, YASUHIRO

Inventor Search Completed: No Records to Display.

<b>Search Another: Inventor</b>	<b>Last Name</b>	<b>First Name</b>	<input type="button" value="Search"/>
	<input type="text" value="Iijima"/>	<input type="text" value="Yasuhiro"/>	

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